

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

PATENT APPLICATION

Inventors: Stephen P. DeOrnellas et al.

SC/Serial No.: Unknown

Filed: Herewith

Title: METHOD FOR USING A HARD MASK
FOR CRITICAL DIMENSION GROWTH
CONTAINMENT

Customer No. 23910

2/A
C7
1/11/00

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Matthew A. Mahling (Signature)
Matthew A. Mahling
Signature Date: October 19, 2000

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Preliminary to the examination of the above-referenced continuation case, please amend the claims as follows:

In the Claims:

Please amend the following claims as indicated below. Please add the new claims set forth below. All pending claims are included for completeness.

- A' 1. (Amended) A method for [containment of] minimizing critical dimension growth of [a] the width of features located on a workpiece [substrate] including the steps of:

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